

IN ,THE UNITED STATES PATENT AND TRADEMARK OFFICE

1945.P2/SILICON/MBE

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| In re Application of: | Group Art Unit: 1746 |
| Chow, et al. | Examiner: Allan Olsen |
| Serial No.: 09/362,924 | |
| Filed: July 27, 1999 | March 20, 2000 |
| For: MULTIPLE STAGE PROCESS FOR CLEANING PROCESS CHAMBER | San Francisco, California |

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Attached hereto is a PTO-1449 form listing documents believed relevant to the subject application. It is respectfully requested that these documents be considered by the Examiner and an initialed copy of the form be returned to the undersigned.

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all documents listed herein are being deposited with the United States Postal Service as first class mail in an envelope address to: Assistant Commissioner for Patents, Washington, D.C. 20231, on March 20, 2000, Vanessa Shieh.

Vanessa Shieh
Signature

Under 37 C.F.R. § 1.97(c), an Information Disclosure Statement shall be considered by the Office if filed after three months from the filing date of the application, but before the mailing date of the final action or notice of allowance, provided the statement is accompanied by a certification as specified in Paragraph (e).

As required under § 1.97(e), applicant hereby certifies that each item of information contained in this Supplemental Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

Therefore, it is believed that no fee is due for the filing of this Supplemental Information Disclosure Statement. If any fee is due, the Commissioner is hereby authorized to charge payment of any such fees, or credit any overpayment, to Deposit Account No. 10-0258.

Also, if any Petition is required for the filing of this Supplemental Information Disclosure Statement, such Petition is requested herein.

It should be noted that the word "prior" has been deleted from the form.

A copy of each document is enclosed.

Some of the documents may have markings thereon. No significance is meant to be attached to the markings.

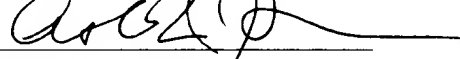
With regard to any translations which may be provided herewith, the undersigned does not know how and who made the translations. Therefore, no representation is being made as to the accuracy of any translation.

These documents are not necessarily analogous.

Respectfully submitted,

JANAH & ASSOCIATES
A PROFESSIONAL CORPORATION

Date: 3/20/00

By: 
Ashok K. Janah
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Please continue to send all correspondence to:

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Encl.